



INTERNATIONAL
GEMOLOGICAL
INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

December 28, 2024

IGI Report Number

Description

Shape and Cutting Style

Measurements

LG671464242

LABORATORY GROWN DIAMOND

EMERALD CUT

8.75 X 6.16 X 3.98 MM

GRADING RESULTS

Carat Weight

Color Grade

Clarity Grade

2.09 CARATS

E

VS 1

ADDITIONAL GRADING INFORMATION

Polish

Symmetry

Fluorescence

EXCELLENT

EXCELLENT

NONE

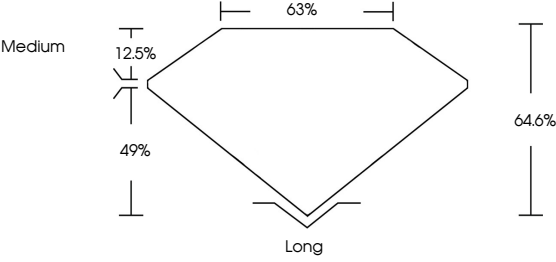
Inscription(s)

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

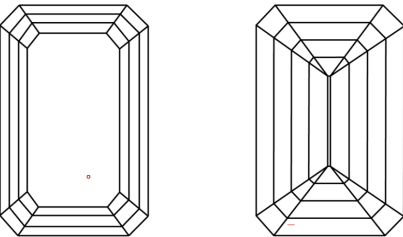
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Report verification at igi.org

PROPORTIONS



CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.

Green symbols indicate external characteristics.

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Girdle

Culet

Polish

Symmetry

Fluorescence

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2.09 CARATS

E

VS 1

64.6%

63%

Medium

Long

EXCELLENT

EXCELLENT

NONE

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IGI



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